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			APPLICANT(S) Jeong-Ki KIM, Dong-Suk BAE, Yang-Gi KIM, Seung-Min PARK and Chae-Kyu KIM		
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U.S. PATENT DOCUMENTS					
EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS
U.S. PATENT APPLICATION PUBLICATIONS					
	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS
U.S. PATENT APPLICATIONS					
	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS
FOREIGN PATENT DOCUMENTS					
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS
	JP 4-153792	05/27/1992	Japan (Full Japanese Text & English Abstract)		X
	JP 4-213129	08/04/1992	Japan (Full Japanese Text & English Abstract)		X
	JP 6-282702	10/07/1994	Japan (Full Japanese Text & English Abstract)		X
	JP 7-191892	07/28/1995	Japan (Full Japanese Text & English Abstract)		X
	JP 9-231110	09/05/1997	Japan (Full Japanese Text & English Abstract)		X
OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)					
Japanese Office Action dated August 21, 2008					
EXAMINER			DATE CONSIDERED		

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